

APPLICANT'S ART CITATION <small>(Use several sheets if necessary)</small>		Application 10/542,276		OFGS File No. P/4745-3		
		Applicant Kyung-Hwa PARK				
		Filing Date July 14, 2005		Group Art Unit		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
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FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation
						Yes
	NZ 517258	09-2002	New Zealand			X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Examination Report issued by New Zealand Patent Office on October 12, 2005 in connection with corresponding patent application no. 541034				
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